Highest Flexibility

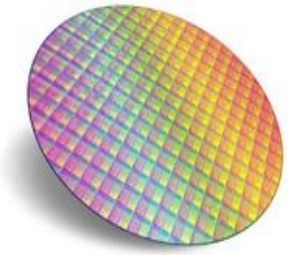
Supreme performance for Ambitious Reactive Sputtering – Production of Flat Panel Displays, Solar Cells, Decorative / Hard Coatings.

MAGPULS Bi-Polar Pulse Power Supply series MP2 are designed for operating with dual magnetrons for reactive sputtering on substrates like glass, plastic & metal & semiconductors. Individual operating modes and enhanced ARC-management allows MP2 Pulse Power Supplies operate very effectively in achieving high quality coatings. Typical applications are production of Flat Panel Displays, Solar Cells, Decorative & Hard Coatings.

MP2 series comprises of mainly two units. First unit is the DC power supply which provides DC power into the big capacitor bank of the pulse unit. Second unit is the Pulsar, an intelligent circuitry, which is equipped with highly sophisticated ARC management capability. MP2 series units are available with output power range from **3 kW up to 60 kW** and pulse current from **35 A up to 400 A** peak current.

MP2 Duty Cycle can be adjusted individually for each half wave to achieve higher target utilisation & for better optimisation of the processes. Enhanced ARC management provides best coating results without process interruptions. Optionally, MP2 series provide an external Optical Input Interface for external controlling of the pulse times externally. It also has as an Optical Output Interface for triggering or synchronization of other bipolar pulse power supplies of series MP1 or MP2.

FEATURES	*BENEFITS & ADVANTAGES*
Adjustable Pulse Parameters & Frequency	Universal Application Range - One power supply
6 Different Output operating modes	Optimal adjustment of process for better process stability
DC, Uni-Polar, Bi-Polar Pulse & Prog Pulse Train	Better control of power - optimized target utilization
Enhanced Effective ARC management	Quick Arc-suppression. Lowest Arc-energy. Best results
Independent +ve and -ve Pulse & Arc Parameters	Highly Effective results for Dual Sputtering processes



VOLTAGE PULSING – Descrete Advantage

MAGPULS' MP2 Pulse Generators are designed on Voltage Pulsing Technology (VPT). Unlike in Current Pulsing Technology, user can set the amplitude of the Pulse (voltage) in VPT Pulsars. This provides a very tight control on the process. Stable plasma condition is easily achievable at low pulsing frequencies, well below 100kHz. Pulsing current is in correlation with the plasma impedance & temperature stress on the coating products can be controlled very effectively.

Technical Data

OUT PUT	MP2-35	MP2-100	MP2-200	MP2-400
Voltage	0 – 1000 V	0 – 1000 V	0 – 1000 V	0 – 1000 V
Current	0 – 5.3 A DC 0 – 35 A Pulse	0 – 38 A DC 0 – 100 A Pulse	0 – 50 A DC 0 – 200 A Pulse	0 – 120 A DC 0 – 400 A Pulse
Power	0 – 3 kW DC	0 – 15 kW DC	0 – 30 kW DC	0 – 60 kW DC
Pulse Frequency	DC / 0.05 Hz – 100 kHz			
Max. Frequency with Max. Pulse Current	100 kHz @ 10 A 25 kHz @ 35 A	100 kHz @ 25 A 20 kHz @ 100 A	100 kHz @ 50 A 20 kHz @ 200 A	100 kHz @ 80 A 20 kHz @ 400 A
Pulse Time Settings T_{on+} / T_{on-} / T_{off+} / T_{off-}	2.0 µs up to 100 sec	2.0 µs up to 100 sec	2.0 µs up to 100 sec	2.0 µs up to 100 sec
Duty Cycle	0.005 % to 100 %			
Pulse wave form	DC + DC – Uni-Polar + Pulse	Uni-Polar – Pulse Bi-Polar Pulse Programmable Pulse Train		
IN PUT				
Max. Voltage	0 – 1000 V DC	0 – 1000 V DC	0 – 1000 V DC	0 – 1000 V DC
Max. Current	0 – 5.3 A DC	0 – 38 A DC	0 – 50 A DC	0 – 120 A DC
Max. Power	0 – 3 kW DC	0 – 15 kW DC	0 – 30 KW DC	0 – 60 KW DC
Mains Supply	1 Φ 230 V AC 50/60 Hz or 1 Φ 115 V AC 50/60 Hz			
ARC-MANAGEMENT				
I_{max} - Detection	0 to ± 35 A peak	0 to ± 100 A peak	0 to ± 200 A peak	0 to ± 400 A peak
ARC – Detection Time	< 200 ns	< 200 ns	< 200 ns	< 200 ns
Off Time after ARC Detection	30 µs up to 1000 ms			
ARC – Recovery Time	≥ 100 µs	≥ 100 µs	≥ 100 µs	≥ 100 µs
di/dt Dynamic Change	Var. di/dt threshold: 0A/µs up to 2000A/µs			
Voltage Drop ΔU	Var. U threshold: 0% up to 100% U_{DC} (Option)			
U x I – Cross Detection	Var. U threshold 0V up to 1000V Var. I threshold: 0.1 x max. Ipeak up to 1 x max. Ipeak (Option)			
INTERFACE				
Analog	1 (up to 3) 15 pin-Sub-D for controlling external DC power supplies			
Digital	15 pin Sub-D user Interface with floating potential contactors			
RS 232	9 pin Sub_D			
Ethernet	RJ 45			
Profibus	9 pin Sub-D (Option)			
TEMP MANAGEMENT				
Cooling System	Air cooling	Water cooling		
Cooling Temperature	Max. 35°C	20°C – 30°C		
Cooling Medium	Air	Water (Max water pressure 6 bar)		

Technical Data

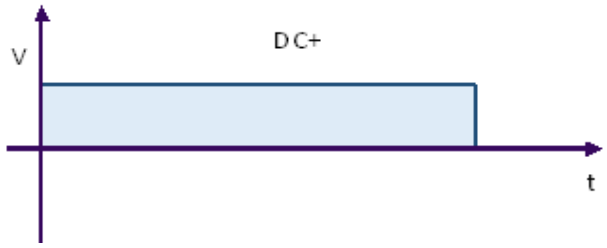
ENV CONDITION	MP2-35	MP2-100	MP2-200	MP2-400
Ambient Temperature	+5° C up to +35° C			
Max. Humidity	80 % non condensing			
Max. Operating Altitude	1500 m above sea level			
MECHANICAL DATA				
Construction	19" – rack 5 HU			19" – rack 10 HU
Dimension H x W x D	222.25 mm x 483 mm x 650 mm			
Weight	25 kg	32 kg	36 kg	65 kg
DISPLAY & CONTROLS				
Display	Graphic color Display			
LED Display	Power, OK, Start / Stop			
Controls	Graphical Menu via Function Keys, Arrow keys & Continuous Rotating Knob			

BP Symmetric & BP Asymmetric

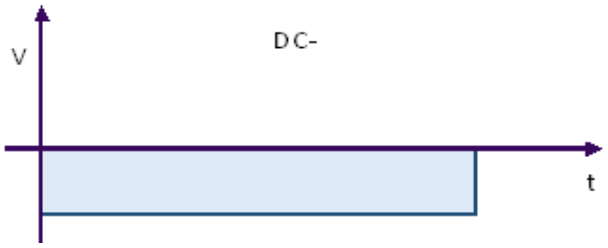
MP2 Pulse Generators are available in 2 variants : Bi-Polar Symmetric (MP2-S) & Bi-Polar Asymmetric (MP2-AS). In Symmetric variant , +ve and -ve Pulses will have the same Pulse Voltage settings, whereas in Asymmetric variant, user can set different values for Pulse Voltage outputs. This gives the user higher control and advantage in the Dual Magnetroc Sputteirng processes.

OUT PUT Wave Forms

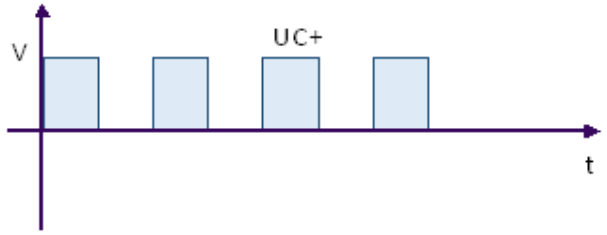
DC + Output



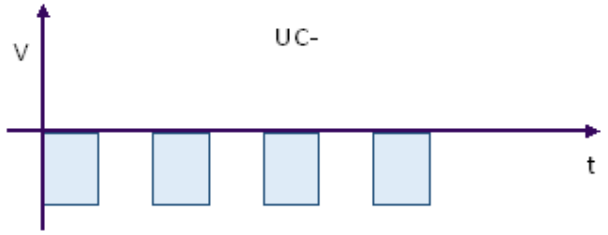
DC - OutPut



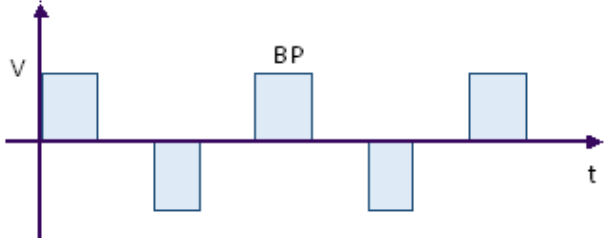
Uni-Polar + Pulse Output



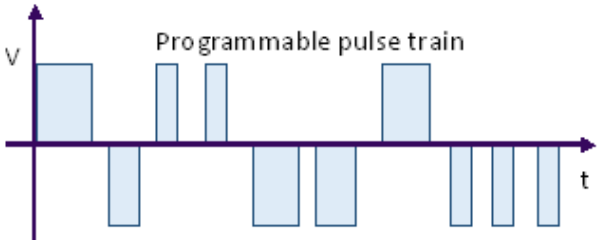
Uni-Polar - Pulse OutPut



Bi-Polar Pulse Output



Programmable Pulse Train OutPut

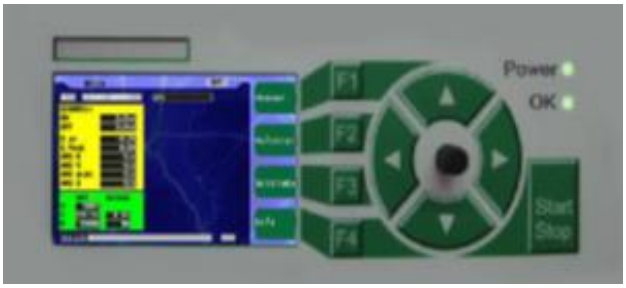


PRODUCT Images

Front Facia with DC power supply

Rear side with connecting cables

Control Panel



LCD Display Panel

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